

10/500975

DT15 Res'd PCT/PTO 08 JUL 2004

Docket No.: 50389-052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Chihiro KAWAI, et al.

Serial No.:

Group Art Unit:

Filed: July 08, 2004

Examiner:

For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

PRELIMINARY AMENDMENT

Mail Stop Preliminary Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: